## Hyeong Min Jin

## List of Publications by Year in descending order

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		361045	344852
37	1,411	20	36
papers	citations	h-index	g-index
39	39	39	2390
all docs	docs citations	times ranked	citing authors

#	Article	IF	CITATIONS
1	Highly tunable refractive index visible-light metasurface from block copolymer self-assembly. Nature Communications, 2016, 7, 12911.	5.8	143
2	Au–Ag Core–Shell Nanoparticle Array by Block Copolymer Lithography for Synergistic Broadband Plasmonic Properties. ACS Nano, 2015, 9, 5536-5543.	7.3	130
3	Laser Crystallization of Organic–Inorganic Hybrid Perovskite Solar Cells. ACS Nano, 2016, 10, 7907-7914.	7.3	123
4	Laser Writing Block Copolymer Self-Assembly on Graphene Light-Absorbing Layer. ACS Nano, 2016, 10, 3435-3442.	7.3	102
5	Flexible and Transferrable Selfâ€Assembled Nanopatterning on Chemically Modified Graphene. Advanced Materials, 2013, 25, 1331-1335.	11.1	88
6	Flash Light Millisecond Selfâ€Assembly of High χ Block Copolymers for Waferâ€Scale Subâ€10 nm Nanopatterning. Advanced Materials, 2017, 29, 1700595.	11.1	78
7	Ultralarge Area Sub-10 nm Plasmonic Nanogap Array by Block Copolymer Self-Assembly for Reliable High-Sensitivity SERS. ACS Applied Materials & Samp; Interfaces, 2018, 10, 44660-44667.	4.0	59
8	3D Tailored Crumpling of Blockâ€Copolymer Lithography on Chemically Modified Graphene. Advanced Materials, 2016, 28, 1591-1596.	11.1	58
9	Smart Nanostructured Materials based on Selfâ€Assembly of Block Copolymers. Advanced Functional Materials, 2020, 30, 1902049.	7.8	56
10	Atomic Layer Deposition Assisted Pattern Multiplication of Block Copolymer Lithography for 5 nm Scale Nanopatterning. Advanced Functional Materials, 2014, 24, 4343-4348.	7.8	55
11	Electrical Biomolecule Detection Using Nanopatterned SiliconÂvia Block Copolymer Lithography. Small, 2014, 10, 337-343.	5.2	48
12	2D Metal Chalcogenide Nanopatterns by Block Copolymer Lithography. Advanced Functional Materials, 2018, 28, 1804508.	7.8	41
13	Anomalous Rapid Defect Annihilation in Self-Assembled Nanopatterns by Defect Melting. Nano Letters, 2015, 15, 1190-1196.	4.5	37
14	Three-Dimensional Silicon Electronic Systems Fabricated by Compressive Buckling Process. ACS Nano, 2018, 12, 4164-4171.	7.3	36
15	Block Copolymer Nanopatterning for Nonsemiconductor Device Applications. ACS Applied Materials & Lamp; Interfaces, 2022, 14, 12011-12037.	4.0	36
16	Perovskite Light-Emitting Diodes via Laser Crystallization: Systematic Investigation on Grain Size Effects for Device Performance. ACS Applied Materials & Samp; Interfaces, 2018, 10, 2490-2495.	4.0	34
17	Device-oriented graphene nanopatterning by mussel-inspired directed block copolymer self-assembly. Nanotechnology, 2014, 25, 014008.	1.3	29
18	Electric field directed self-assembly of block copolymers for rapid formation of large-area complex nanopatterns. Molecular Systems Design and Engineering, 2017, 2, 560-566.	1.7	29

#	Article	IF	Citations
19	Large-area, highly oriented lamellar block copolymer nanopatterning directed by graphoepitaxially assembled cylinder nanopatterns. Journal of Materials Chemistry, 2012, 22, 6307.	6.7	25
20	Self-Assembly of Complex Multimetal Nanostructures from Perforated Lamellar Block Copolymer Thin Films. ACS Applied Materials & Samp; Interfaces, 2017, 9, 15727-15732.	4.0	22
21	Laser-Directed Self-Assembly of Highly Aligned Lamellar and Cylindrical Block Copolymer Nanostructures: Experiment and Simulation. Macromolecules, 2018, 51, 1418-1426.	2.2	21
22	Soft crystal martensites: An in situ resonant soft x-ray scattering study of a liquid crystal martensitic transformation. Science Advances, 2020, 6, eaay5986.	4.7	20
23	Controlled Segmentation of Metal Nanowire Array by Block Copolymer Lithography and Reversible Ion Loading. Small, 2017, 13, 1603939.	5.2	19
24	Nanodomain Swelling Block Copolymer Lithography for Morphology Tunable Metal Nanopatterning. Small, 2014, 10, 3742-3749.	5.2	18
25	Sculpted grain boundaries in soft crystals. Science Advances, 2019, 5, eaax9112.	4.7	18
26	Bimodal phase separated block copolymer/homopolymer blends self-assembly for hierarchical porous metal nanomesh electrodes. Nanoscale, 2018, 10, 100-108.	2.8	17
27	Conformal 3D Nanopatterning by Block Copolymer Lithography with Vapor-Phase Deposited Neutral Adlayer. ACS Nano, 2019, 13, 13092-13099.	7.3	15
28	Nanopatterns with a Square Symmetry from an Orthogonal Lamellar Assembly of Block Copolymers. ACS Applied Materials & District Science (2019, 11, 20265-20271.	4.0	13
29	Single-step self-assembly of multilayer graphene based dielectric nanostructures. FlatChem, 2017, 4, 61-67.	2.8	8
30	Largeâ€Area Alignment of Supramolecular Columns by Photothermal Laser Writing. Advanced Materials, 2020, 32, 2002620.	11.1	7
31	Negativeâ€Tone Block Copolymer Lithography by In Situ Surface Chemical Modification. Small, 2014, 10, 4207-4212.	<b>5.2</b>	6
32	Highly Aligned Carbon Nanowire Array by E-Field Directed Assembly of PAN-Containing Block Copolymers. ACS Applied Materials & Samp; Interfaces, 2020, 12, 58113-58121.	4.0	6
33	2D Nanopatterning: 2D Metal Chalcogenide Nanopatterns by Block Copolymer Lithography (Adv. Funct.) Tj ETQq1	1.0.7843 7.8	14 rgBT /
34	Directed high  block copolymer <scp>selfâ€assembly</scp> by laser writing on silicon substrate. Journal of Applied Polymer Science, 2022, 139, .	1.3	3
35	Evaluation of nonlinear pre-sampled modulation transfer function in iterative reconstruction CT. , 2013, , .		1
36	Wafer-Scale Unidirectional Alignment of Supramolecular Columns on Faceted Surfaces. ACS Nano, 2021, 15, 11762-11769.	7.3	1

#	Article	IF	CITATIONS
37	Self-Assembly Nanofabrication via Mussel-Inspired Interfacial Engineering. Applied Mechanics and Materials, 0, 229-231, 2749-2752.	0.2	0